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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10092617	FILING DATE 03/08/2002	CLASS 478 257	SUBCLASS 446	GAU 576	EXAMINER STAL
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**APPLICANTS: Kondo Takaharu; Okabe Shotaro; Sano Masafumi; Sakai Akira;
Hayashi.Ryo; Sugiyama Shuichiro;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 039353/2001 03/12/2001
JAPAN 039355/2001 03/12/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO
03500.016270.

TITLE : Semiconductor element, and method of forming silicon-based film

U.S. DEPT. OF COMM./PAT. & TM-PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
		Sheets Drwg.	Figs. Drwg. Print Fig.
Primary Examiner		Application Examiner	
PREPARED FOR ISSUE			
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